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**** CONTINUING DATA ********none JN***** FOREIGN APPLICATIONS ********none JN***IF REQUIRED, FOREIGN FILING LICENSE GRANTED ****

06/22/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY ID	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		12	49	6
Verified and Acknowledged	<i>JN</i> Examiner's Signature	<i>JN</i> Initials			

ADDRESS

021567

TITLE

Deposition apparatuses, methods of assessing the temperature of semiconductor wafer substrates within deposition apparatuses, and methods for deposition of epitaxial semiconductive material

FILING FEE RECEIVED 1550	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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